

Electronic Acknowledgement Receipt

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Application Number:	10549334
International Application Number:	
Confirmation Number:	6690
Title of Invention:	Crystallization apparatus and method of amorphous silicon
First Named Inventor/Applicant Name:	Su-Gyeong Lee
Customer Number:	22150
Filer:	Frank Chau/Susan Ramunto
Filer Authorized By:	Frank Chau
Attorney Docket Number:	8071-103 (OPP052118US)
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Application Type:	U.S. National Stage under 35 USC 371

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part /.zip	Pages (if appl.)
1	Request for Corrected Filing Receipt	8071-103RequestCorrectedF R.pdf	1023762	no	14

Warnings:

Information:**Total Files Size (in bytes):**

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.